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PATENT MECENT Docket No. 81877.0607 8 2002 Room

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO, et al.

Serial No: 09/670,917

Filed: September 29, 2000

For: SEMICONDUCTOR DEVICE MANUFACTURING METHOD AND APPARATUS FOR REMOVING SILICON NITRIDE FORMED IN A REACTION CONTAINER (AS AMENDED)

Art Unit: Examiner: GUERRERO, Maria F.

> I hereby certify that this correspondence is being deposited with the United States Fostal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner

for Patents, Washington, D.C. 20231,

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Kimberly Yee

06/20/02 Date

Name

ASSOCIATE POWER OF ATTORNEY

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

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Respectfully submitted,

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